

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 10/567,729 Confirmation No. 7682
Applicant : Kazutoshi Kojima et al.
371 Filed : February 1, 2006
Art Unit : 2814
Examiner : Sarah Kate Salerno
Customer No. : 00270
Title : SILICON CARBIDE EPITAXIAL WAFER, METHOD FOR PRODUCING SUCH WAFER, AND SEMICONDUCTOR DEVICE FORMED ON SUCH WAFER

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Sir:

This is an Amendment in response to a non-final Office Action dated September 3, 2008. Kindly amend the application as set forth below.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.